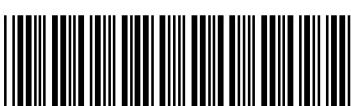


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	09450609	WEIBEL ET AL.
	Examiner	Art Unit
	Kim, Jennifer	1617

SEARCHED

Class	Subclass	Date	Examiner
514	257, 250	2/1/2007	jmk
	updated	10/15/2007	jmk
514	266.1, 256, 258.1, 365, 369, 257, 250	6/9/2008	jmk

SEARCH NOTES

Search Notes	Date	Examiner
inventor search updated; see search terms	2/1/2007	jmk
updated	10/15/2007	jmk
Updated	6/9/2008	jmk

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
514	257, 250	6/9/2008	jmk
514	266.1, 256, 258.1, 365, 369	6/9/2008	jmk